
Magnetic Materials Processes and Devices 11

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Table of Contents

Preface *iii*

Chapter 1 **Electrodeposition of Soft and Hard Magnetic Materials: Fundamentals and Nanostructures**

Proton Transport during Electrodeposition of Cobalt in Chloride Electrolytes 3
O. E. Kongstein, G. Haarberg, and J. Thonstad

Aqueous Electrodeposition and Mechanism of Iron Group-Vanadium Ternary Alloys 19
M. Schwartz, B. Yoo, and K. Nobe

Assembly and Embedding of Nanoparticles in a Ni-Matrix 33
M. Wurz, P. Wagner, L. Rissing, and J. Caro

Electrodeposition of Ni/Cu Multilayers Nanowires Using Alumina Template 43
P. Cojocaru, A. Leserri, L. Magagnin, M. Vázquez, and G. Carac

Chapter 2 **Magnetic MEMS and Devices**

(Invited) Active Magnetic Micro and Nano Electro-Mechanical Systems (MNEMS) 53
H. H. Gatzert

Fabrication of MEMS on Printed Circuit Boards 69
S. Cvetkovic, A. Wienecke, and L. Rissing

Investigations on Micromolds for Dispensing Low Viscosity Epoxies for MEMS Applications 81
C. H. Leng, C. Ruffert, and L. Rissing

Process Development of an Electroplated Permalloy Layer on Magnetic Magnesium for Intelligent Products 93
A. Belski, M. Wurz, and L. Rissing

Chapter 3
Patterned Media and Nanoparticles

(Invited) Development on Self-Assembly Technique for Arrangement of Chemically Synthesized FePt Nanoparticles <i>T. Hachisu, A. Sugiyama, and T. Osaka</i>	107
Author Index	115